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Direct chemical vapor deposition synthesis of large area single-layer brominated graphene⁺

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Graphene and its derivatives such as functionalized graphene are considered to hold significant promise in numerous applications. Within that context, halogen functionalization is exciting for radical and nucleophilic substitution reactions as well as for the grafting of organic moieties. Historically, the successful covalent doping of sp² carbon with halogens, such as bromine, was demonstrated with carbon nanotubes. However, the direct synthesis of brominated graphene has thus far remained elusive. In this study we show how large area brominated graphene with C–Br bonds can be achieved directly (*i.e.* a single step) using hydrogen rich low pressure chemical vapor deposition. The direct synthesis of brominated graphene could lead to practical developments.

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1. Introduction

Since its isolation in 2004, graphene has been a center of attention because of its fascinating properties.¹ However, currently many of the synthesis routes being actively pursued for graphene sheet production no longer generate pristine graphene; rather, graphene is covalently functionalized to tailor its chemical and physical properties towards certain applications.^{2,3} For example graphene oxide is much easier to process than pristine graphene due to its high solubility.⁴ Similarly, nitrogen functionalization has been shown to drastically increase the electrocatalytic activity of graphene.² Bromine functionalization of graphene related materials like carbon nanotubes (CNTs) has been reported decades ago.^{5,6} Bromine functionalized CNTs have been demonstrated as a versatile

^aCollege of Chemistry & Molecular Engineering, Peking University, Beijing 100871, P. R. China precursor for covalent functionalization and as an efficient agent in gas sensing electrodes.^{7,8} Bromine is known to be an efficient leaving group in radical and nucleophilic substitution reactions that well suit grafting organic moieties such as polymer surfaces with OH, SH and NH₂ functionalities.⁹ The bromine functionalized graphene has been demonstrated to induce properties such as p type doping,^{10–12} oxygen reduction reaction (ORR) activity,¹³ reversible bromine storing,¹⁴ sulphide ion detection¹⁵ and electrocatalytic decomposition of H₂O₂ in graphene.¹⁶ Besides, C–Br bonds are well suited for efficient grafting of organic moieties on graphene that can be used for various purposes, including electrochemical and electronic devices.^{17,18}

However, direct bromine functionalization of pristine graphene is relatively less known, mainly due to the chemically inert nature of pristine graphene.19 Moreover, the direct synthesis of Br doped graphene with C-Br bonds (as opposed to adsorbed Br₂), thus far, has remained elusive. Most production routes for brominated graphene use indirect synthesis approaches and include thermal treatments,12 solution-phase synthesis,13 chemical bromination14 the plasma bromination of graphene,17 a halogen atmosphere during exfoliation of graphene oxide,18 post treatments of graphite bromide19 and CVD synthesized graphene.²⁰ However, the indirect and multistep procedures to fabricate Br-doped graphene are time consuming (and thus typically more expensive), low yield and increase the risk of impurities in the final product beside the resultant materials are complex and only coarse control over product stoichiometry is achievable. Thus, there remains a crucial need to develop a facile approach for the direct and large-scale synthesis of Br-doped graphene. This will help pave the way to



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utilize brominated graphene in its various attractive applications at industrial level.

In light of these observations, we felt that it would be of interest to carry out large-area bromination of graphene *via* facile chemical vapor deposition (CVD) synthesis. The CVD growth of graphene on copper foil is particularly popular due to its distinct advantages such as easy transfer, large scale, and low cost.²¹ The catalytic growth mechanism on Cu foil surface in the CVD process allows different materials as graphene carbon and dopant source.²² We have established the first single-step CVD synthesis route for mono- and few- layer large graphene doped with bound bromine (C–Br bond), as opposed to adsorbed Br₂. This was achieved using a single solid precursor of 1,2,5,6,9,10-hexabromocyclododecane in a H₂ rich atmosphere as shown in Fig. 1a.

In our synthesis route, the precursor simultaneously serves as the source of C and Br. A hydrogen rich environment is chosen since H_2 acts as a co-catalyst during the formation of active (surface bound) carbon species $(C_xH_y)_z$ required for efficient growth. In addition, it can etch away weak carbon–carbon bonds.²³ Parametric studies with precursor zone temperature allow us to optimize for single-layer large area graphene. X-ray photoemission studies confirm the presence of C–Br bonding. Thus, our fabrication approach demonstrates the direct synthesis of brominated graphene by CVD is possible.

2. Materials and methods

2.1. Graphene growth

Bromine doped graphene was synthesized directly on a 25 μ m thick copper substrate in a horizontal tube furnace at a pressure of 0.5 mbar. 1,2,5,6,9,10-Hexabromocyclododecane (Fig. 1a) was used as the source of both Br and C and was purchased from Haihang Industry Co., Ltd. And was used as received. 0.5 mg of this precursor powder was placed upstream (by the closed end of an inner reactor tube). The copper strip (45 \times 10 mm) was rolled and carefully placed inside the inner reactor tube at a distance of 25 mm from its open end (opposite end to the precursor). This smaller quartz tube was then placed inside the main CVD furnace quartz tube as shown in Fig. 1b. The system was then evacuated to a pressure of 0.1 mbar with the help of a rotary pump. Afterwards, the system was flushed with pure Ar

(99.99%) gas at a flow of 200 standard cubic centimeters per minute (SCCM) to reduce residual background gases. The Ar flushing was stopped after 30 minutes and switched to pure H₂ (99.99%) flow at 16 sccm (at a pressure of 0.5 mbar). The furnace was heated to 1025 °C in 45 minutes. During heating, the oven remained at the copper foil (substrate) end of the inner quartz tube as indicated by heating position in Fig. 1b. Once the reaction temperature was reached, the CVD oven was slid towards the precursor end indicated by growth position in Fig. 1b to obtain the controlled evaporation of the precursor. The explored temperatures for the precursor were 150, 200, 250, 300 and 350 °C, where optimal growth was found at 200 °C for uniform monolayer graphene. The optimum growth time was 3 minutes. After growth the CVD oven was moved away from the reaction region to provide rapid cooling of the copper substrate and bring the reaction to a rapid stop.24 The hydrogen flow was stopped and switched back to 200 sccm of Ar until the furnace had cooled down to room temperature. A detailed graphical representation of the CVD protocol steps are shown in the ESI in Fig. S1.[†] Moreover, before starting every experiment the inner quartz tube was subsequently washed with acetone, ethanol and deionized water then blow dried with N2. Afterwards it was oxidized at 1025 °C for 30 minutes in the main CVD quartz tube to remove any source of contamination coming from the tube or the previous experiment.

2.2. Transfer

The bromine-doped graphene was transferred on to standard lacey carbon Cu TEM grids for TEM and HRTEM studies. For that purpose, first the copper substrate was spin-coated with a PMMA solution in ethyl acetate, followed by its etching in 0.5 molar aqueous solution of ammonium persulphate (Sigma Aldrich, purity \geq 98%) for ~100 minutes. Thereafter it was rinsed thoroughly in deionized water. The film was then fished in deionized water onto a standard lacey carbon Cu TEM grid. The PMMA coating was removed in hot acetone vapor.²⁵ Finally, to remove any organic residue that might have lifted, the TEM grid was annealed in high vacuum (10⁻⁶ mbar) at 200 °C for 12 hours.²⁶

For SEM and Raman characterizations, instead of a TEM grid SiO_2 (300 nm)/Si wafer was used as the substrate for transfer. The wafer was sonicated in pure acetone followed by washing in

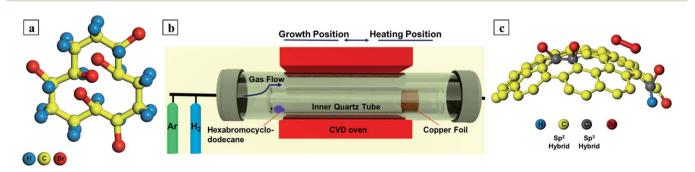


Fig. 1 (a) Precursor (1,2,5,6,9,10-hexabromocyclododecane) stick and ball model (b) CVD set up and protocol (c) stick and ball model showing side view C–Br graphene (sp³-like bonding) and surface adsorbed Br_2 (based on ref. 17).

absolute ethanol and then drying in N_2 . The graphene film was fished onto it and then annealed in an oven at 75 °C for 20 minutes. Afterwards, PMMA was removed by dipping it (for 2 minutes) in pure acetone.

2.3. Characterization

The large area brominated graphene was characterized through SEM on a Hitachi SU-8010. TEM and HRTEM characterization was performed on a Titan³ 80–300 with an electron acceleration voltage of 80 kV. Raman spectra and mapping were collected on a Horiba (Confocal LabRAM HR 800) using 633 nm laser while keeping the laser power at 2 mW. XPS was performed on a Thermo Fisher Scientific (model ESCALAB 250 xi). The FTIR spectrum was recorded in the ATR mode on a Tensor 27 spectrometer from Bruker Optics. The sheet resistance was measured through a SZT-C four-probe test bench Suzhou Jingge electronics.

3. Results and discussion

To synthesize our brominated graphene, a CVD reactor setup employing a half closed inner quartz tube configuration (Fig. 1b) was used. The use of the inner quartz tube configuration is helpful in trapping of reaction species that forms on decomposition of the precursor and allows their slow diffusion out of the reactor tube, thus provides sufficient time for graphene formation, in particular for powder precursors.²⁷ With this set up even 0.5 mg of precursor material was enough to form large area brominated graphene. However, the rate at which the precursor sublimes and decomposes is affected by the precursor heating rate. Therefore, while the reaction zone (where the Cu substrate resides) was kept at a constant temperature of 1025 °C, different temperatures at the precursor heating zone were explored to optimize the reaction for the formation of (large area) monolayer brominated graphene. The growth time was maintained at 3 minutes.

Precursor heating zone temperatures from 150 °C to 350 °C with 50 °C steps where explored. In all cases clear modes corresponding to sp² carbon presence were observed (Fig. 2a–e). These modes are the D peak (\sim 1340 cm⁻¹), the G peak (\sim 1580 cm⁻¹) and the 2D mode (\sim 2700 cm⁻¹) but with variation in their relative intensities.²⁸ Moreover, for all the samples, the G band appeared at 1588 cm⁻¹ with a slight upshift of 8 cm⁻¹ and the 2D band appeared at 2642 cm⁻¹ with a down shift of 58 cm⁻¹ than the usual values concomitant with Br doping.^{12,29} This is further confirmed by presence of the D band presence that arise due to defects and doping from Br.²⁹

For all precursor heating temperatures, the 2D peak amplitude intensity is slightly larger than that for the G peak. In addition, the 2D peak is narrow (with a full width at half maximum (FWHM) of *ca.* 40 cm⁻¹) indicating the presence of predominantly monolayer graphene.²⁷ As one increases the precursor heating temperature the peaks in the Raman spectra show changes. For the precursor heating temperature of 150 °C the intensity of the 2D peak is comparatively lower. While measuring the graphene fragments, the signal was weak with large signal to noise ratio suggesting the graphene flakes were inhomogeneous. However, the 2D to G mode and the G to D ratio suggest the fragments are graphene (Fig. S2b[†]). By acquiring scanning electron micrographs from the samples one can obtain a better impression of the samples to further explain the Raman data. The SEM data in Fig. 2f suggests that when precursor was heated at 150 °C there was insufficient feedstock of active precursor species and thus continuous graphene layer could not be formed in this case. On increasing the precursor heating temperature further to 200 °C, the intensity of 2D band become higher and it was more symmetric. FWHM of 2D peak also got lower as compared to that of 150 °C Fig. S2a.† The corresponding SEM image in Fig. 2g shows continuous full coverage graphene. On increasing the precursor heating temperature to 250 °C the 2D band of Raman spectrum in Fig. 2c experienced an obvious decrease in its intensity and its FWHM also increased Fig. S2a.[†] The corresponding SEM image in Fig. 2h shows some secondary graphene islands forming over the initial graphene layer. Moreover, the precursor heating temperature at 300 °C resulted in corresponding increase in FWHM of the 2D peak Fig. S2a† although the change in 2D band intensity was negligible. The corresponding SEM image in Fig. 2i showed a regular patched structure of the grown graphene. This indicates that the flakes are becoming larger with rising precursor heating temperature. The Raman and SEM data fit will with each other. The D mode is present in all cases with a G/D of around 5 to 6 Fig. S2b.† The D mode is attributed to defects, including Br doping.^{30,31} The Raman spectroscopy data with the SEM micrographs shows that the optimum precursor zone temperature is at ca. 200 °C for large area homogenous single-layer graphene. Additionally a detailed Raman mapping data in Fig. S3.[†] from brominated single layer graphene was used to investigate the uniformity of the grown graphene.32 Raman maps were taken over 30 micrometer square area. The data shows that the brominated graphene is large area and crystalline.

On increasing the temperature further to 350 °C the corresponding 2D peak in Fig. 2e got wider, shorter and higher in its frequency (appearing at 2660 cm⁻¹).²⁸ Its FWHM value also increased to 63 cm⁻¹ (Fig. S2a†) and was no longer symmetric. The G band also showed a small red shift of 2 cm⁻¹ with the increased number of layers and appeared at 1586 cm⁻¹.²⁸ This indicated a multi-layer graphene formation. The D peak rose tremendously higher than both G and 2D peaks. The result was in agreement with the corresponding SEM image in Fig. 2j that shows a highly defective graphene. This can be attributed to the anisotropic etching effect of pure H₂ that has become more dominant with increased precursor heating temperature.³³

In case of the single-layer brominated graphene, further characterizations by transmission electron microscopy (TEM) were conducted as shown in Fig. 3. Low magnification studies show uniform large area deposition graphene in Fig. 3a. High resolution TEM (HRTEM) studies show that the graphene formed was predominantly monolayer. This was confirmed by forming holes (through electron beam irradiation)³⁴ and visually confirming the layer number, as can be seen, for example, at the top left of Fig. 3b. Higher magnification studies of the

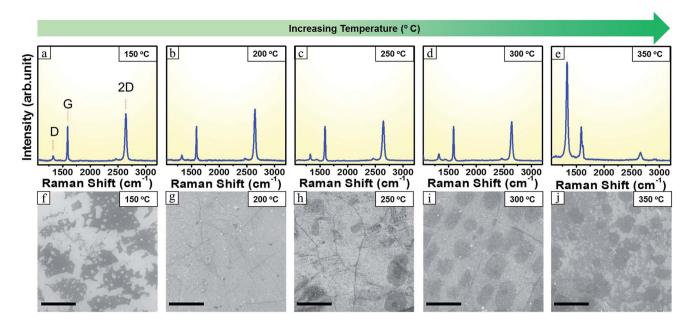


Fig. 2 (a-e) Raman spectra recorded at the different precursor temperature. All spectra normalized w.r.t G mode (f-j) corresponding SEM images. Scale bar 5 μ m.

material show a nicely crystalline honeycomb lattice concomitant with graphene in Fig. 3c. Moreover, the only one set of six fold symmetric SAED pattern also confirmed the monolayer nature of the brominated graphene in Fig. 3d and e.³⁵

To better comprehend the nature of the bromine doping in graphene, we conducted core level spectroscopy using X-ray photoemission spectroscopic (XPS). The low resolution long range survey spectrum in Fig. 4a reveals a predominant C 1s peak at 284.3 eV and additional peaks at 257 eV, 182 eV, 70.5 eV corresponding to the Br 3s, Br 3p, Br 3d.^{36,37} In addition, an O 1s signature at 531 eV and a Cu 2p peaks (at 933 eV) are observed.^{36,38} The atomic percentage of Br is *ca.* 3.5% while that for C is 49.7%. The O and Cu contributions, which are attributed to the substrate are 4.3% and 41.8%, respectively.^{39,40} The high resolution C 1s main peak in Fig. 4b can be fitted into three components centered at 284.3 eV, 285.1 eV and 286.5 eV that can be ascribed to C==C, C-C/C-H and C-O/C-Br respectively.³⁶ The relative percentages of each of these three peaks are 43.7%, 25.9% and 30% respectively. The larges fraction is due to sp² C

(graphene), the second to a more sp³-like fraction with C/H and the lowest fraction due to C–Br.²⁹

Furthermore, to show unequivocally that there is a C-Br fraction, we look in more detail at the Br 3d XPS response from bromine in Fig. 4c. Similar to previous studies on brominated CNTs two peak pairs are of observed here due to the different types of bromine bonds.²⁹ A very weak doublet at the lower energies of 64.3 eV and 65.4 eV corresponds Br 3d_{5/2} lines. The doublet at higher energy with edges at 69.9 eV and 72.3 eV corresponds to Br 3d_{3/2} lines.²⁹ Among each set of the doublet pairs the low lying peaks at 64.3 \pm 0.2 and 69.9 \pm 0.2 are assumed to arise from the physically adsorbed bromine derivatives such as carbon charge transfer Br2 complexes and BrH.41 Due to covalent bond formation between C and Br, a more stable and stronger interaction occurs and the high energy components at 65.4 \pm 0.2 and 72.3 \pm 0.2 is assigned to C-Br bond that confirms the formation of brominated graphene.^{29,42,43} The C-Br content was determined as 1.8% while the Br₂ content is *ca.* 2% (error $\pm 0.1\%$). The XPS data confirms

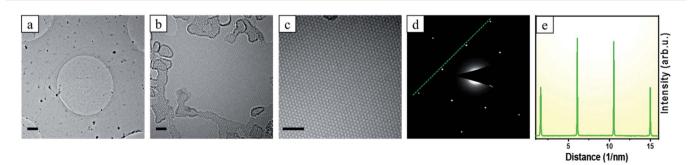


Fig. 3 (a) TEM image shows large area deposition of the Br doped graphene. Scale bar 2 μm (b and c) HRTEM images showing the Br doped graphene is single layer. Scale bar 1 nm (d and e) SAED data and intensity profiles over the {1010} and outer {1120} reflexes showing the formed graphene is monolayer. The dark pointer in (d) is the shadow of the beam stop used to block the intense direct beam.

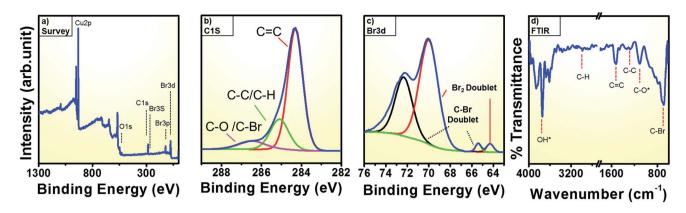


Fig. 4 (a) Long range XPS survey spectrum for optimized precursor heating at 200 °C (b) high resolution C 1s spectrum (c) high resolution Br 3d spectrum (d) ATR spectrum in transmission mode. Adsorptions in ambient labelled with *.

the presence of a C–Br bond in the graphene. Indeed, the electrophilic addition of bromine across the graphene double bond changes the sp² hybrid character to a more sp³-like geometry.¹⁷

We also examined the Cu data. The Cu 2p spectrum in Fig. S4a[†] from the Cu substrate shows the presence of shake up bands suggest there may be a little oxidized Cu (due to defects (*e.g.* grain boundaries or perhaps the bromination sites)).³⁸ To better comprehend this we look at the O 1s spectrum (Fig. S4b[†]), which show two peaks at 529.8 eV and 531 eV can be attributed to Cu₂O/CuO and C–O respectively.^{39,44} The respective atomic percentages for C–O and Cu₂O/CuO are *ca.* 2.5% and 2.4%. This indicates that a small fraction of the brominated graphene is also oxidized. It is unclear if this occurs at defects sites after exposure to air or during synthesis.^{39,42}

We additionally look at the functional groups of the brominated graphene with FTIR. In the FTIR spectrum (Fig. 4d) the peaks at ~1250 cm⁻¹ and ~1100 can be attributed to C–C and C–O vibrations, respectively.⁴⁵ The peak at *ca.* 1530 cm⁻¹ is due to the C=C stretching mode and appears as a strong peak.^{45,46} An intense peak at 690 cm⁻¹ is attributed to C–Br and further supports the formation of brominated graphene.^{8,45,46} The absorption in the region from 3600 to 3700 cm⁻¹ is due to surface adsorbed OH species from the ambient.⁴⁶ The absorption due to C–H bond is assigned at 2987 cm⁻¹.⁴⁶ Thus, the XPS and FTIR data all confirm presence of covalently bonded Br. The FTIR data correlate very well with the XPS results.

Finally, we also examined the sheet resistance of the brominated graphene sheets, produced under different precursor heating temperature, using the four probe sheet resistance method. (Fig. S2c†) For the precursor heating temperature of 150 °C the sheet resistance cannot be measured due to absence of any continuous layer formation at this temperature. For the precursor heating temperatures of 200, 250 and 300 °C, the corresponding sheet resistance increased with increasing temperature. This can be correlated with SEM data where increasing the temperature led to the formation of additional secondary graphene layers as islands over the initial large area graphene. These additional islands provide scattering sties that thereby increase in the sheet resistance.^{47,48}

4. Conclusions

In summary, we have developed the first direct, scalable and simple single step CVD process for large area, single layer, crystalline graphene with covalently doped bromine. We achieve this by using 1,2,5,6,9,10-hexabromocyclododecane as the powder precursor for Br and C species in a hydrogen rich environment. Indeed, this is the first report to show that direct synthesis of brominated graphene through CVD is possible. Moreover, the single solid precursor that acts as the elemental feedstock for both C and Br yields crystalline, large area and monolayer brominated graphene. The successful direct facile single step formation of brominated graphene by CVD thus offers a scalable pathway for the synthesis of a versatile spectrum of graphene derivatives suitable for a range of potential applications.¹⁴

Conflicts of interest

There are no conflicts to declare.

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